Electronic Acknowledgement Receipt		
EFS ID:	1045065	
Application Number:	09917842	
Confirmation Number:	3573	
Title of Invention:	ATOMIC LAYER DEPOSITION APPARATUS	
First Named Inventor:	Barry L. Chin	
Customer Number:	32588	
Filer:	Keith Patrick Taboada	
Filer Authorized By:		
Attorney Docket Number:	5017/ISM/CORE MCVD/SB	
Receipt Date:	11-MAY-2006	
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Application Type:	Utility	
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Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1		APPM_5017Y2_EAMEND_5 _06.pdf	333288	yes	11

	Multipart Description			
	Doc Desc	Start	End	
	Amendment after Notice of Allowance (Rule 312)	1	1	
	Amendment Copy Claims/Response to Suggested Claims	2	9	
	Applicant Arguments/Remarks Made in an Amendment	10	11	
Warnings:				

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.